



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 19, 2026

IGI Report Number

LG826615186

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MODIFIED PENTAGONAL MIXED CUT

Measurements

8.84 X 6.88 X 3.40 MM

GRADING RESULTS

Carat Weight

1.04 CARAT

Color Grade

E

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

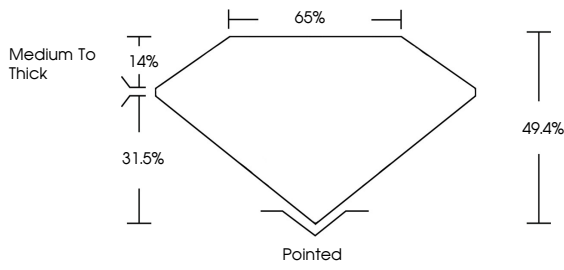
NONE

Inscription(s)

 LG826615186

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

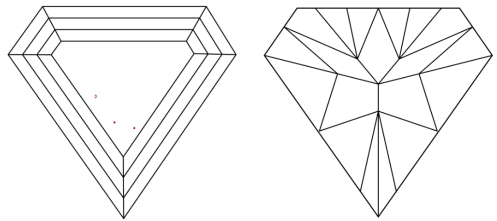
PROPORTIONS



Medium To Thick

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



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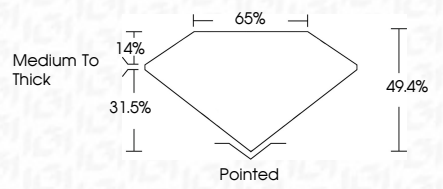
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8.84 X 6.88 X 3.40 MM

Carat Weight

1.04 CARAT

Color Grade

E

Clarity Grade

VVS 2

Depth

31.5%

Table

14%

Girdle

Medium To Thick

Culet

Pointed

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

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